

<b>Notice of References Cited</b>	Application/Control No. 10/616,716	Applicant(s)/Patent Under Reexamination ADACHI ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,824,920	11-2004	Iwamoto et al.	429/218.1
	B	US-			
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	D	US-			
	E	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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	N	WO00/33403	06-2000	JP	Iwamoto	H01M 4/02
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
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